



INTERNATIONAL
GEMOLOGICAL
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LABORATORY GROWN DIAMOND REPORT

August 22, 2026

IGI Report Number

LG825669282

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUSHION STEP CUT

Measurements

8.10 X 5.92 X 3.85 MM

GRADING RESULTS

Carat Weight

1.52 CARAT

Color Grade

E

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

NONE

Inscription(s)

 LG825669282

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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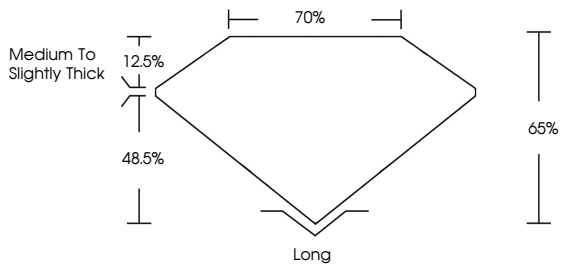
NONE

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PROPORTIONS

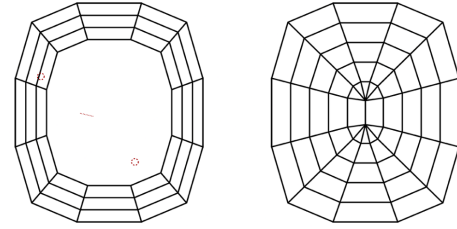


Medium To Slightly Thick



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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IGI

August 22, 2026

IGI Report No LG825669282

CUSHION STEP CUT

8.10 X 5.92 X 3.85 MM

Carat Weight

1.52 CARAT

Color Grade

E

Clarity Grade

VS 2

Depth

65%

Table

70%

Girdle

Medium to Slightly Thick

Culet

Long

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

NONE

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Type IIa